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Kassir, Salman M.

Serial No.: 10/059,701

Filed: January 29, 2002

For: Method of Spin Etching

Wafers With an Alkali

Solution

Art Unit: 2812

led: January 29, 2002

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TRANSMITTAL OF SUPPLEMETNAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313

Sir:

Enclosed please find Applicant's Information Disclosure Statement.

Date: June 17, 2003 By:

K. David Crockett, Esq.

Reg. No. 34,311

Certificate of Mailing (37 CFR 1.8)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Post Office on June 17, 2003 with postage prepaid in an envelop addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313.

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FORM PTO-1449 (REV. 7-80) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

212/361

SERIAL NO.

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10/059,701

LIST OF PRIOR ART CITED BY APPLICANT

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Kassir, Salman M.

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January 29, 2002

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				U.S. PATENT DOCUMENTS		G	ROUP 17	
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
-	AA	4,343,662	8/82	Gay	148	187		
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		OTHER PRIOR AF	RT (includ	ing Author, Title, Date, Pertin	ent Pages	s, Etc.)		
		US 2001/00391	19 A1, K	ishimoto, published 11/8/01,	filed 1	1/22/99.		
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Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant